
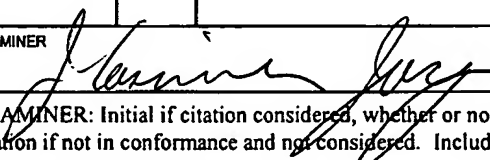


Subst. Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Docket Number (Optional) 56231-433 (MKSK-134)		Application Number 10/814,973		
				Applicant A. Shajii et al.				
				Filing Date March 30, 2004		Group Art Unit		
U. S. Patent Documents								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
CJ	A	4,796,854	01/10/89	Ewing	251	129.07	05/18/87	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
CJ	B	© 2000 MKS Instruments, Inc., "Pressure-Based Mass-Flo® Controller For Ion Implant Applications Type 1640," Bulletin 1640 - 4/00.						
CJ	C	© 2000 MKS Instruments, Inc., "Metal-Sealed Mass-Flo® Controller Type 1479A," Bulletin 1479A-5/00.						
EXAMINER 				DATE CONSIDERED 6/21/05				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.								

Subst. PTO-1449 (1-94)